

IPW

00862.023399

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUHITO TAKANASHI ET AL.

Application No.: 10/754,531

Filed: January 12, 2004

For: ETCHING METHOD

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Examiner: Not Yet Assigned
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Group Art Unit: 1746
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May 12, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

A. Introductory Comments

Prior to conducting the examination on the merits, please amend the
above-captioned application as follows and consider the following remarks.